

【ABSTRACT】

The present invention relates to a gas treatment system and a ship including same. The gas treatment system includes a reliquefaction unit for reliquefying a gaseous material discharged from a storage tank, wherein the
5 storage tank stores at least one of a first material and a second material, the reliquefaction unit includes: a first cooler for cooling the gaseous first material by means of a refrigerant; and a second cooler for cooling the refrigerant, and the second cooler is used to cool the second material.

Fig. 2

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